

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Wang, et al.

Serial No.: 10/046,954

Confirmation No.: 4418

Filed:

January 14, 2002

For:

Semiconductor Wafer

Preheating

MAIL STOP RCE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

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Group Art Unit: 2125

Examiner:

Kidest Bahta

**CERTIFICATE UNDER 37 CFR 1.10** 

I hereby certify that this correspondence and the documents referred to as attached therein are being deposited on 2005 with the United States Postal Service in an envelope as "Express Mail Post Office to Addressee," mailing label No. <a href="EV321685281US">EV321685281US</a> addressed to: Mail Stop RCE, Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

4/14/05

Signature

## REQUEST FOR NON-ENTRY OF AMENDMENT

Applicants respectfully request non-entry of the Response filed by facsimile on February 10, 2005, to the Final Office Action dated December 14, 2004. Applicants also respectfully request non-entry of the Response filed by facsimile on March 11, 2005, to the Final Office Action dated December 14, 2004.

Respectfully submitted,

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